



Docket No. 740756-2721

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)
Shunpei YAMAZAKI et al.)
Application No. 10/806,353) Art Unit: 2812
Filed: March 23, 2004) Confirmation No. 3995
For: A METHOD FOR MANUFACTURING)
SEMICONDUCTOR DEVICE) Date: August 4, 2004

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

U.S. Patent and Trademark Office
220 20th Street, South
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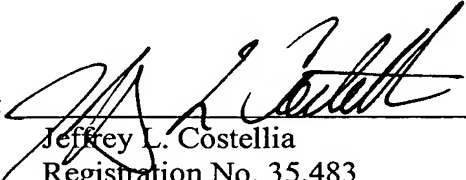
Sir:

Supplemental to the Information Disclosure Statement filed March 23, 2004, and in accordance with the duty of disclosure as set forth in 37 C.F.R. §1.56, Applicants hereby submit the following information in conformance with 37 C.F.R. §§ 1.97 and 1.98. Pursuant to 37 C.F.R. § 1.98, a copy of each of the documents cited is enclosed.

It is requested that the accompanying PTO-1449 be considered and made of record in the above-identified application. To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

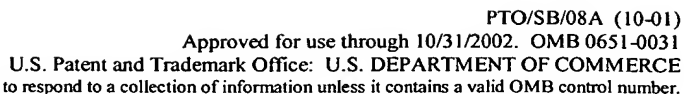
Respectfully submitted,

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

Patent Number	10/806,353
Filing Date	March 23, 2004
First Named Inventor	Shunpei YAMAZAKI et al.
Art Unit	2812
Confirmation No.	3995
Attorney Docket Number	740756-2721

Sheet	1	of	1
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Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.